



Practitioner's Docket No. 14912.833

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Stephen E. Savas et al. )  
Serial No.: 09/997,158 ) Group No.: 1763  
Filed: November 28, 2001 ) Examiner: Luz L. Alejandro Mulero  
For: Systems and Methods for Enhancing )  
Plasma Processing of a Semiconductor )  
Substrate )

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TC 1700

MS Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

Applicants submit this Amendment in response to the Office Action mailed on March 21, 2003. Reconsideration of the above referenced application is respectfully requested in view of the following amendments and remarks.

09/25/2003 CNGUYEN 00000019 232415 09997158

01 FC:1253 930.00 DA

09/25/2003 CNGUYEN 00000020 232415 09997158

01 FC:1202 35.00 DA